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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **Hidemasa KAI et al.**

Art Unit: **1763**

Application Number: **10/626,675**

Examiner: **Ram N. Kackar**

Filed: **July 25, 2003**

Confirmation Number: **1831**

For: **EPITAXIAL WAFER PRODUCTION APPARATUS AND SUSCEPTOR
STRUCTURE**

Attorney Docket Number: **030901**

Customer Number: **38834**

PETITION FOR EXTENSION OF TIME

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

March 5, 2008

Sir:

Applicant petitions the Commissioner for Patents to extend the time for response to the Office Action dated September 5, 2007 for three (3) months from December 5, 2007 to March 5, 2008.

Attached please find a check in the amount of \$1,050.00 for the cost of the extension of time. If any additional fees are due in connection with this paper, please charge Deposit Account No. 50-2866.

Respectfully submitted,

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